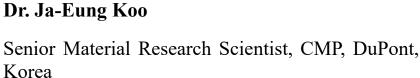


Korean International Semiconductor Conference & Exhibition on Manufacturing Technology 2025

KISM 2025 BUSAN

Re:Innovation of Semiconductor Manufacturing for AI Ecosystem





Ja-Eung Koo is a material research scientist in CMP R&D team of DuPont. He received the Ph.D. degree in department of Chemistry from KAIST in 2002. Starting from 2002, as an engineer in CMP Process Development team of Samsung Electronics, he was involved in searching for next generation CMP processes with new pads, slurries, and chemicals. Since 2022, he moved to DuPont and has been working for CMP pad development.